

Information Disclosure Citation in an Application	Application No.	Applicant(s)		
	09/862,814	John C. Seibel et al. #7 SP		
	Docket Number	Group Art Unit	Filing Date	
	067082.0114	2177	5/21/01	

DEC 19 2003

U.S. PATENT DOCUMENTS

	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
A	4914586	4/3/90	Swinehart et al.	364	200	11/6/87
B	6034970	3/7/00	Levac et al.	370	466	7/2/97
C	6199081	3/6/01	Meyerzon et al.	707	513	6/30/98
D	6493703	12/10/02	Knight et al.	707	3	5/11/99
E	6609124	8/19/03	Chow et al.	707	5	8/13/01
F	6611839	8/26/03	Nwabueze	707	101	3/15/01
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FOREIGN PATENT DOCUMENTS

	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
						YES
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NON-PATENT DOCUMENTS

	DOCUMENT (Including Author Title Source and Pertinent Pages)	DATE
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EXAMINER

Kun S. Lin

DATE CONSIDERED

2/18/2004

EXAMINER: Initial if citation considered whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.